

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nicholas A. WARD et al.

Serial No. 09/927,444

Filed: August 3, 2001

For: DYNAMIC CONTROL OF WAFER PROCESSING PATHS IN
SEMICONDUCTOR MANUFACTURING PROCESSING

Group Art Unit: 2125

Examiner: SHECHTMAN, Sean P.

HONORABLE COMMISSIONER FOR PATENTS
Alexandria, VA 22313

Dear Sir:

Transmitted herewith is a Response in the above identified application.

- ☐ No additional fee is required.
- ☐ Small Entity Status has been previously established.
- ☐ Also attached:
- ☒ The fee has been calculated as shown below:

LARGE ENTITY

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	52	52	0	x \$50 =	\$0.00
Independent Claims	6	6	0	x \$200 =	\$0.00
If multiple claims newly presented, add \$290.00					
Fee for extension of time					\$1,020.00
TOTAL FEE DUE					\$1,020.00

[X] Please charge my Deposit Account No. 08-0219 in the amount of \$1,020.00. An additional copy of this transmittal sheet is submitted herewith.

[X] The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 08-0219, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

WILMER CUTLER PICKERING HALE AND DORR LLP

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